

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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M. Braunsen

4/23/03

Applicant(s): Vyvoda, et al.	Group Art Unit: 2814
Application No.: 09/776009	Examiner: Anh D. Mai
Filed: 02/02/2001	
Title: Wafer Surface that Facilitates Particle Removal	
Attorney Docket No.: 40025.003 (MSI-1)	FAX RECEIVED JAN 14 2003 TECHNOLOGY CENTER 2800

Assistant Commissioner for Patents

Washington, D.C. 20231

AMENDMENT AND RESPONSE**I. Status of Claims:**

Claims 1-14 and 30-56 have been rejected under 35 USC 102 and 103.

AMENDMENT

Please enter the following amendment and remarks in response to the Office

Action of October 15, 2002.

IN THE SPECIFICATION

Please amend paragraph [0030], on page 10, line 19 to page 11, line 2, as follows.

Appendix A contains a marked-up version of this paragraph showing the changes being made.

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Date: January 14, 2003

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TO: Commissioner for Patents
Attn: Anh D. Mai
Patent Examining Corps
Facsimile Center
Washington, D.C. 20231

FROM: Pamela J. Squyres

OUR REF: MA-027

TELEPHONE: 408-869-2921

FAX NUMBER 703-308-7722

* Please deliver to Examiner Anh D. Mai in Art Unit 2814. *

Document(s) Transmitted: Fax Cover Sheet (1 pg.)
Transmittal Form (1pg)
Amendment and Response (14 pgs)
Two Statements Under 37 CFR 3.73 (b) (2 pgs)
Two Powers of Attorney (2pgs)

Total pages of this transmission, including cover letter: 20 pgs.

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Re:

Patent Application of: Michael A. Vyvoda et al.

Examiner: Anh D. Mai


Serial No.: 09/776009

Group Art Unit: 2814

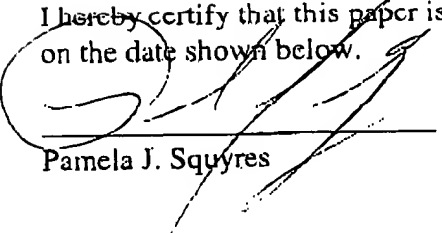
Filed: February 2, 2001

Docket No.: MA-027

Title: Wafer Surface that Facilitates Particle Removal

By: 
Name: Pamela J. Squyres
Reg. No.: 52,246

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